

Notice of References Cited	Application/Control No. 10/684,435	Applicant(s)/Patent Under Reexamination CHANG, LIN-WEI	
	Examiner Boris L. Chervinsky	Art Unit 2835	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,995,364	11-1999	McAnally et al.	361/685
*	B	US-6,040,981	03-2000	Schmitt et al.	361/695
*	C	US-6,075,698	06-2000	Hogan et al.	361/695
*	D	US-6,236,564	05-2001	Fan, Cheng-Yuan	361/695
*	E	US-6,349,031	02-2002	Lin et al.	361/685
*	F	US-6,375,440	04-2002	Kosugi, Naofumi	417/423.14
*	G	US-6,556,437	04-2003	Hardin, George T.	361/687
*	H	US-6,587,342	07-2003	Hsu, Cheng-Chung	361/695
*	I	US-6,663,416	12-2003	Huang et al.	439/485
*	J	US-6,674,641	01-2004	Jensen et al.	361/687
*	K	US-6,808,411	10-2004	Chen, Li Ping	439/485
*	L	US-6,817,939	11-2004	Gan et al.	454/184
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	X	

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